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(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

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09/770,289

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Atsushi SHIOTA, et al.

FILING DATE

January 29, 2001

GROUP

1712

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| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
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| MF | AA | 6,207,555 B1 | 03/27/2001 | Matthew ROSS | | | |
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| | | | | | YES | NO |
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| MF | AW | J.J. YANG, et al., "Electron Beam Curing of Siloxane SOG for Non-etch Back Process". Advanced Metallization & Interconnect Systems for ULSI Applications in 1996: Materials Research Society Conference Proceedings, ed. Robert Havemann, et al., May 1997, pp. 505-509. |
| MF | AX | J.J. YANG, et al., "Integration of Spin-on Low-k Dielectrics Using E-Beam Curing for ULSI Multilevel Interconnects". Advanced Metallization and Interconnect Systems for ULSI Applications in 1997: Materials Research Society Conference Proceedings, ed. R. Cheung, et al., March 1999, pp. 359-365. |
| | AY | Applied Materials' assertion that Matthew Ross is a co-inventor of the 09/770,289 application. See discussion in Amendment filed herewith. |

☐ Additional References sheet(s) attached